

RECEIVED
CENTRAL FAX CENTER

JUN 02 2005

REPLY UNDER 37 CFR 81.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:		Attorney Docket No.:
Chi-Chun Chen, et al.	§	2002-0066 / 24061.461
Serial No.: 10/600,393	§	Customer No. 42717
Filed: June 20, 2003	§	Group Art Unit: 2822
For: METHOD OF FORMING DUAL GATE INSULATOR LAYERS FOR CMOS APPLICATIONS	§	Examiner: Toniae M. Thomas
	§	Confirmation No.: 8529

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence (including any listed enclosures) is being facsimile transmitted (703-672-9306) to the United States Patent and Trademark Office on June 2, 2005.

Kelly A. Moreau
Kelly A. Moreau

Sir:

AMENDMENT UNDER 37 C.F.R. 81.116
IN REPLY TO ADVISORY ACTION

This Amendment is submitted in reply to the Advisory Action mailed on May 23, 2005, and in reply to the Office Action mailed on March 25, 2005. (Please see the pages that follow).

Not okay to enter. JMT 06/16/05